

PATENT APPLICATION

Applicant: Vitali Nesterenko et al.

Conf. No.: 3552

Filed: May 2, 2006

For: ISOSTATIC PRESSURE
ASSISTED WAFER BONDING
METHOD

Art Unit: 2823

Examiner: Stark, Jarrett J.

AMENDMENT E

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

In response to the Final Office Action mailed March 5, 2009, and the Advisory Action mailed June 30, 2009, please amend the above-identified application as follows.

Applicants petition the Commissioner of Patents and Trademarks to extend the time for response to the Office Action dated February 3, 2009 for two months.